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MAR 17 2005
PATENT & TRADEMARK OFFICE

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Docket No.:0756-7210

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of	)	
Hirotada OISHI	)	
Serial No. 10/684,416	)	Group Art Unit: 1725
Filed: October 15, 2003	)	Examiner: S. Heinrich
For: LASER IRRADIATION APPARATUS	)	
AND METHOD OF MANUFACTURING	)	
SEMICONDUCTOR DEVICE BY USING THE		
LASER IRRADIATION APPARATUS		

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria VA 22313-1450, on March 15, 2005

Penny A Davis

REQUEST FOR STATUS

Honorable Commissioner of Patents
P. O. Box 1450
Alexandria VA 22313-1450
Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

Eric J. Robinson
Reg. No. 38,285

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